

S/N 10/681,481

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Paul A. Farrar	Examiner:	Joy Watson
Serial No.:	10/681,481	Group Art Unit:	1746
Filed:	October 8, 2003	Docket No:	1303.112US1
Title	METHOD OF CLEANING SEMICONDUCTOR SURFACES		

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PETITION FOR A TWO-MONTH EXTENSION OF TIME

MS RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a two-month extension of time be granted in which to respond to the Final Office Action mailed July 24, 2007, said period of response being extended from October 24, 2007 to December 24, 2007.

**Please charge Deposit Account No. 19-0743 in the amount of \$460.00 to cover the required extension fee. Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.**

Respectfully Submitted,

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.  
P.O. Box 2938  
Minneapolis, MN 55402  
(612) 373-6944

Date: 12-26-07

By: \_\_\_\_\_



David C. Peterson  
Reg. No: 47,857

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 26 day of December 2007.

Name: \_\_\_\_\_

USA Posorske

Signature: \_\_\_\_\_

Sisa Posorske